

(Use as many sheets as necessary)

Sheet	1	of	2
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Application Number	10/725,874
Filing Date	12-02-2003
First Named Inventor	Takahiro OGUCHI
Art Unit	2823
Examiner Name	J. Garza
Attorney Docket Number	36856.1187

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM -YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code 2(if known)			
JAK	1	6,004,874	12/1999	Cleaves	
JAK	2	6,043,001	03/2000	Hirch et al.	
JAK	3	6,172,721	01/2001	Murade et al.	
JAK	4	6,313,030	11/2001	Kikuta	
JAK	5	5,654,244	08/1997	Sakai et al.	
JAK	6	6,177,351	01/2001	Beratan et al.	
JAK	7	6,261,953	07/2001	Uozumi	
JAK	8	6,207,976	03/2001	Takahashi et al.	
JAK	9	6,140,142	10/2000	Ikeda et al.	
JAK	10	5,385,867	01/1995	Ueda et al.	
JAK	11	5,405,797	01/1995	Brugger	

[illegible]

Examiner Signature	<i>James A. Davis</i>	Date Considered	<i>June 28, 2005</i>
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This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14.

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Attorney Docket Number	36856.1187

[illegible]

**Examiner
Signature**

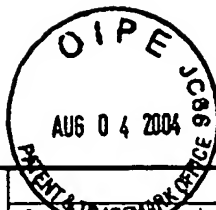
Joanni A. Garza

Date	
Considered	

June 28, 2015

¹ Applicant unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14.

PTO/SB/08A (04-03)



PTO/SB/08A (04-03)

Substitute for form 1449/PTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Sheet 2 of 2**Complete if Known**

Applicant Number	10/725,874
Filing Date	December 2, 2003
First Named Inventor	Takahiro OGUCHI
Art Unit	2856 2823
Examiner Name	unknown J. Garcia
Attorney Docket Number	36856.1187

NON PATENT LITERATURE DOCUMENTS

Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title Of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
JAK	8	ZHIXIONG et al., "LATERALLY CAPACITY SENSED ACCELEROMETER FABRICATED WITH THE ANODIC BONDING AND THE HIGH ASPECT RATIO ETCHING", Solid-State and Integrated Circuit Technology 1998 Proceedings, 5 th International Conference in Beijing, China, Oct. 21-23, 1998, pp. 921-924, IEEE, Piscataway, NJ.	
JAK	9	MOCHIDA et al., "A MICROMACHINED VIBRATING RATE GYROSCOPE WITH INDEPENDENT BEAMS FOR THE DRIVE AND DETECTION MODES", Micro Electro Mechanical Systems 1999, MEMS '99, 12 th IEEE International Conference in Orlando, FL, Jan. 17-21, 1999, pp. 618-623, IEEE, Piscataway, NJ.	
JAK	10	KLASSEN et al., "SILICON FUSION BONDING AND DEEP REACTIVE ION ETCHING: A NEW TECHNOLOGY FOR MICROSTRUCTURES", Proc. Of Transducers '95, 8 th International Conference on Solid-State Sensors and Actuators, Stockholm, Sweden, June 25-29, 1995, pp. 556-559, Vol. 1.	
JAK	11	FRANSSILA et al., "ETCHING THROUGH SILICON WAFER IN INDUCTIVELY COUPLED PLASMA", Microsystem Technologies, , April 2000 (2000-04), pp. 141-144, vol. 6, no. 4, Berlin, DE.	

Examiner Signature	<i>J. Garcia</i>	Date Considered	June 28, 2004
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*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered, include copy of this form with next communication to applicant.

¹ Applicant unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14.

INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

Sheet	1	of	1
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First Named Inventor	Takahiro OGUCHI
Art Unit	2823
Examiner Name	J. Garai
Attorney Docket Number	36856.1187

[illegible][illegible]

Examiner Signature	<i>Johnnie A. Davis</i>	Date Considered	<i>June 28, 2008</i>
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